

| | | | | |
|-----------------------------------|---------------------------------------|--|---|-------------|
| Notice of References Cited | Application/Control No. 10/599,653 | | Applicant(s)/Patent Under Reexamination OOMURA, HIROSHI | |
| | Examiner Nicholas C. Pachol | | Art Unit 2625 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|------------------|----------------|
| * | A | US-5,371,837 A | 12-1994 | Kimber et al. | 358/1.15 |
| * | B | US-5,638,497 A | 06-1997 | Kimber et al. | 358/1.15 |
| * | C | US-5,903,716 A | 05-1999 | Kimber et al. | 358/1.13 |
| * | D | US-6,333,789 B1 | 12-2001 | Shima, Toshihiro | 358/1.15 |
| * | E | US-2002/0156947 A1 | 10-2002 | Nishio, Masahiro | 710/36 |
| * | F | US-2008/0034127 A1 | 02-2008 | NISHIO, Masahiro | 710/011 |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) | | | |
|---|---|---|--|--|--|
| | U | | | | |
| | V | | | | |
| | W | | | | |
| | X | | | | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.